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What is claimed is:

1. A piezoelectric device for an injector, built into an injector and generating driving force of said injector, characterized in that:

said piezoelectric device is fabricated by alternately laminating a plurality of piezoelectric layers generating displacement in proportion to an applied voltage and a plurality of internal electrode layers for supplying the applied voltage; and

in said piezoelectric device, a relation d(0.1Ec)/d(1.2Ec) > 0.43 is established, where Ec is coercive electric field which causes the changing of polarizing direction, between an apparent piezoelectric constant d(1.2Ec) calculated from static elongation when an electric field of 1.2 Ec is applied to said piezoelectric device in the same direction as a polarizing direction while a preset load of 500 N is applied to said piezoelectric device, and an apparent piezoelectric constant d(0.1Ec) calculated from static elongation when an electric field of 0.1 Ec is applied to said piezoelectric device in the same direction as the polarizing direction.

- 2. A piezoelectric device for an injector according to claim 1, wherein a relation $d(0.1Ec)/d(1.2Ec) \ge 0.5$ is established between said piezoelectric constant d(1.2Ec) and said piezoelectric constant d(0.1Ec).
- 3. A piezoelectric device for an injector, built into an injector and generating driving force of said injector, characterized in that:

said piezoelectric device is fabricated by alternately laminating a plurality of piezoelectric layers generating displacement in proportion to an applied voltage and a plurality of internal electrode layers for supplying the applied voltage; and

said piezoelectric device has a change ratio of displacement of 9% or below when a frequency of

- 4. A piezoelectric device for an injector according to claim 1, wherein said change ratio of displacement is 7% or below.
- 5. A piezoelectric device for an injector, built in an injector and generating driving force of said injector, characterized in that:

said piezoelectric device is fabricated by alternately laminating a plurality of piezoelectric layers generating displacement in proportion to an applied voltage and a plurality of internal electrode layers for supplying the applied voltage; and

in said piezoelectric device, displacement increases with the rise of temperature within the range of $-40\,^{\circ}\text{C}$ to $150\,^{\circ}\text{C}$.

- 6. A piezoelectric device for an injector according to claim 5, wherein said change ratio of displacement is 5 to 40% within the range of temperature of -40° C to 150° C.
- 7. A piezoelectric device for an injector, built 25 in an injector and generating driving force of said injector, characterized in that:

said piezoelectric device is fabricated by alternately laminating a plurality of piezoelectric layers generating displacement in proportion to an applied voltage and a plurality of internal electrode layers for supplying the applied voltage; and

said piezoelectric device has a dielectric loss of 8% or below calculated from a P-E hysteresis.

- 8. A piezoelectric device for an injector 35 according to claim 7, wherein said dielectric loss is 7% or below.
 - 9. A piezoelectric device for an injector built in

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- 46 an injector and generating driving force of said injector, characterized in that: said piezoelectric device is fabricated by alternately laminating a plurality of piezoelectric layers expanding and contracting in proportion to an applied voltage and a plurality of internal electrode layers for supplying the applied voltage; the sectional shape of said piezoelectric device crossing at right angles the laminating direction 10 is an octagon or a polygon with a larger number of sides than octagon; and said piezoelectric device is accommodated in a cylindrical accommodation space. ij 10. A piezoelectric device for an injector according to claim 9, wherein a proximity ratio expressed 15 by (B/A) \times 100 (%), where A is a length of the whole circumference of a circumscribed circle of said piezoelectric device and B is the sum of length of circumferential portions having a distance of 0.2 mm or 20 below between said circumscribed circle and said piezoelectric device, is larger than 17%. 11. A piezoelectric device for an injector according to claim 9, wherein a proximity ratio expressed by $(B/A) \times 100$ (%), where A is a length of the whole circumference of a circumscribed circle of said 25 piezoelectric device and B is the sum of length of circumferential portions having a distance of 0.2 mm or below between said circumscribed circle and said piezoelectric device, is 32% or more. A piezoelectric device for an injector 30 according to claim 9, wherein at least two side surface flat portions having a width of 2.5 mm or more are disposed on a side surface parallel to said laminating direction. 35 13. A piezoelectric device for an injector according to claim 9, wherein an insulating film having a thickness of 0.002 to 0.5 mm is formed at least on the

- 47 surface of a side surface parallel to the laminating direction. 14. A piezoelectric device for an injector according to claim 13, wherein a value R2 - R1, where R1 5 is a maximum outer diameter of said piezoelectric device inclusive of said insulating member and R2 is an inner diameter of said circular cylindrical accommodation space, is 0.5 mm or below. A piezoelectric device for an injector 10 according to claim 13, wherein said insulating film is made of any of a silicone resin, a polyimide resin, an epoxy resin and a fluorocarbon resin. 16. A piezoelectric device for an injector according to claim 9, wherein electrode take-out portions 15 electrically connected to said internal electrode layers are disposed on a distal end face and a rear end face of said piezoelectric device in the laminating direction, respectively. 17. A piezoelectric device for an injector 20 according to claim 9, wherein two electrode take-out portions electrically connected to said internal electrode layer are disposed on either one of a distal end face and a rear end face of said piezoelectric device in the laminating direction. 25 18. A piezoelectric device for an injector according to claim 16, wherein at least one of said electrode take-out portions is electrically connected to at least one of said internal electrode layers through a through-hole formed in said piezoelectric layer. 3.0 19. A piezoelectric device for an injector according to claim 16, wherein at least one of said electrode take-out portions is electrically connected to a side surface disposed on said side surface of said piezoelectric device. 35 A piezoelectric device for an injector built in an injector and generating driving force of said injector, characterized in that:

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said piezoelectric device is fabricated by alternately laminating a plurality of piezoelectric layers expanding and contracting in proportion to an applied voltage and a plurality of internal electrode layers for supplying the applied voltage;

at least a part or the whole of the sectional shape of said piezoelectric device crossing at right angles the laminating direction is arcuate; and said piezoelectric device is accommodated

in a circular cylindrical accommodation space.

- 21. A piezoelectric device for an injector according to claim 20, wherein a proximity ratio expressed by (B/A) x 100 (%), where A is a length of the whole circumference of a circumscribed circle of said piezoelectric device and B is the sum of length of circumferential portions having a distance of 0.2 mm or below between said circumscribed circle and said piezoelectric device, is larger than 17%.
- 22. A piezoelectric device for an injector according to claim 20, wherein a proximity ratio expressed by (B/A) x 100 (%), where A is a length of the whole circumference of a circumscribed circle of said piezoelectric device and B is the sum of length of circumferential portions having a distance of 0.2 mm or below between said circumscribed circle and said piezoelectric device, is 32% or more.
- 23. A piezoelectric device for an injector according to claim 20, wherein at least two side surface flat portions having a width of 2.5 mm or more are disposed on the side surface parallel to the laminating direction.
- 24. A piezoelectric device for an injector according to claim 20, wherein an insulating film having a thickness of 0.002 to 0.5 mm is formed on at least the surface of the side surface parallel to the laminating direction of said piezoelectric device.
 - 25. A piezoelectric device for an injector

- 26. A piezoelectric device for an injector according to claim 24, wherein said insulating film is made of any of a silicone resin, a polyimide resin, an epoxy resin and a fluorocarbon resin.
- 27. A piezoelectric device for an injector according to claim 20, wherein electrode take-out portions electrically connected to said internal electrode layers are disposed on a distal end face and a rear end face of said piezoelectric device in the laminating direction, respectively.
- 28. A piezoelectric device for an injector according to claim 20, wherein two electrode take-out portions electrically connected to said internal electrode layer are disposed on either one of a distal end face and a rear end face of said piezoelectric device in the laminating direction.
- 29. A piezoelectric device for an injector according to claim 27, wherein at least one of said electrode take-out portions is electrically connected to at least one of said internal electrode layers through a through-hole formed in said piezoelectric layer.
- 30. A piezoelectric device for an injector according to claim 27, wherein at least one of said electrode take-out portions is electrically connected to a side surface disposed on said side surface of said piezoelectric device.

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